

**INFORMATION DISCLOSURE CITATION***(Use several sheets if necessary)*

Docket No.

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Application Number

10/599,609

Applicant(s)

OOHASHI et al

Filing Date

10/03/06

Group Art Unit

2814

**U.S. PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**U.S. PATENT APPLICATION PUBLICATIONS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

**FOREIGN PATENT DOCUMENTS**

EXAMINER INITIAL	REF	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
							YES	NO

**OTHER DOCUMENTS***(Including Author, Title, Date Pertinent Pages, ETC.)*

Fujikata, et al., "Surface Plasmon Enhancement Effect and Its Application to Near-Field Optical Recording", Trans. Magn. Soc. Jpn., Vol. 4, No. 4-2, 2004.

"Transactions of the Magnetics Society of Japan", Selected Papers from Magneto-Optical Recording International Symposium, Vol. 4, No. 4-2, No. 15 (2004) <http://www.nil.ac.jp/msj2>, November 2004.

EXAMINER

DATE CONSIDERED

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